

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	GILL	Examiner:	EVANS, J.
Serial No.:	10/811,525	Group Art Unit:	2627
Filed:	03/29/2004	Docket No.:	HSJ920030222US1 (HITG.068-0562)
Title:	METHOD FOR FORMING THIN FILM HEADS USING A BI-LAYER ANTI-REFLECTION COATING FOR PHOTOLITHOGRAPHIC APPLICATIONS AND A STRUCTURE THEREOF		

PETITION FOR EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.136, it is respectfully requested that a one-month extension of time be granted in which to file the attached Amendment. The charge of \$120.00 will be made by credit card.

Respectfully Submitted,

Chambliss, Bahner & Stopfel, P.C.
1000 Tallan Building
Two Union Square
Chattanooga, Tennessee 37402
423-757-0264 • fax 423-508-0264

By: 

Name: David W. Lynch
Reg. No.: 36,204